

03-10-05

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Walter SCHWARZENBACH et al. Confirmation No. 9739
Application No.: 10/733,729 Group Art Unit: 2812
Filing Date: December 12, 2003 Examiner: D. NHU
For: METHOD OF MAKING CAVITIES IN A Atty. Docket No.: 4717-9200
SEMICONDUCTOR WAFER

RESPONSE TO RESTRICTION

Commissioner of Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the Examiner's restriction requirement dated March 3, 2005,
applicants elect method claims 1-19 of Group I for examination in this application.

No fees are believed to be due for this amendment. Should any fees be required,
please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Allan A. Fanucci".

Allan A. Fanucci

(Reg. No. 30,256)

3-9-05

WINSTON & STRAWN LLP
Customer No. 28765
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